

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Takashi MIWA et al.

Appln. No.:

Filed: HEREWITH

For: A SEMICONDUCTOR DEVICE

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the document listed on the attached Form PTO-1449 is hereby cited.

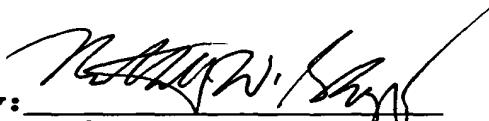
The document on the attached List was cited in the specification, on page 1, and its relevance is indicated therein.

Respectfully submitted,

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By:


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June 27, 2003

FORM PTO-1449		Atty. Docket No.	Appln. No.
<u>LIST OF DOCUMENTS CITED BY APPLICANT</u>		XA-9890	
		Applicant Takashi MIWA et al.	
		Filing Date	Group
		HEREWITH	

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	2002-043531	2/8/02	Japan			Abstract
	AK						
	AL						
	AM						
	AN						
	AO						

OTHER (including author, title, date, pertinent pages, etc.)

AP	
AQ	
AR	

Examiner	Date Considered
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.